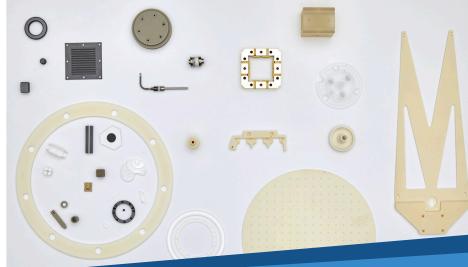


CERAMIC 3D INTERCONNECT DEVICES





TECHNOLOGY

- > High-precision 2D and 3D ceramic components manufacturing
- > Ceramic materials : alumina, aluminium nitride
- > Circuit materials : thin-film PVD Cr/Au, NiCr/Au, Cr/Ni/Au, Ti/Pt/Au, TiW/Au, Cu, Ag...
- > High-accuracy laser ablation of electrical patterns and solder pads : track width 50 μ m (0.002"), insulation pad 50 μ m (0.002") general tolerances < 20 μ m (0.0008")
- > Full wrap-over technology
- > Product size < 1 cm3 up to a few cm3
- > Layers suitable for standard bonding or brazing processes



PRODUCTS - APPLICATIONS

Our typical products

> Chip carriers, substrates, 2.5D and 3D interconnected circuits

Applications

- > MEMS, LED's
- > Optical transponders, infra-red detectors ..
- > Sensors, probes, antenna modules....

Industries

> Optoelectronics, microelectronics, analytical equipment, aerospace, medical, off-shore, energy...



BENEFITS

- > High-performance ceramic materials
- > Dimension stability (heat, temperature variations)
- > Resistance to vibrations
- > Electrical insulation
- > Heat dissipation
- > No outgasing in vacuum
- Chemical inertness
- > Mechanical and electrical functions on the same carrier

